

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of	:	Customer Number: 89518
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CHEN, Hui-Mei, et al.	:	Confirmation Number: 3341
	:	
Application No.: 10/786,807	:	Group Art Unit: 2822
	:	
Filed: February 25, 2004	:	Examiner: AU, Bac H.
	:	
For: METHOD FOR IMPROVING SEMICONDUCTOR WAFER TEST ACCURACY	:	

AMENDMENT

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

It is respectfully requested that the time for response to the final Office Action dated April 1, 2011 be extended for one month to August 1, 2011. Please charge the extension fee of \$130.00 to Deposit Account No. 502624. Please charge any additional fees or credit any overpayment to Deposit Account No. 502624.

In response to the final Office Action dated April 1, 2011, a Request For Continued Examination being filed herewith, please consider the amendments and remarks herein.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks/Arguments begin on page 5 of this paper.